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Synergistic effects of ZnO compact layer and TiCl₄ post-treatment for dye-sensitized solar cells

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ARTICLE INFO

Article history: Received 25 October 2011 Received in revised form 8 December 2011 Accepted 11 December 2011 Available online 24 December 2011

Keywords: Dye sensitized solar cells Zinc oxide compact layer Titanium tetrachloride post-treatment Electrical transport Charge recombination

ABSTRACT

The interaction between ZnO compact layer and TiCl₄ post-treatment on TiO₂ photoelectrode for dye sensitized solar cell (DSSC) is investigated. Photoelectrode combined the two modifications is designated as ZnO+2l+TiCl₄. It is found that after the TiCl₄ treatment the ZnO compact layer transforms to a bi-functional layer, which suppresses back electrons transfer from FTO to electrolyte and reduces the FTO/TiO₂ interfacial resistance. In addition, the newly formed TiO₂ coating generated by TiCl₄ post-treatment contains abundant and well dispersed Zn element, which further facilitates electron transfer at TiO₂ layer. Meanwhile, the electron lifetime in ZnO+2l+TiCl₄ is the longest. Consequently, the overall energy conversion efficiency of the cell with ZnO+2l+TiCl₄ is significantly enhanced to 8.9%, which is 8.8% higher than that with pure TiCl₄ post-treatment and 17.7% higher than that without any treatment. These results are verified by material characterization and corresponding opto-electrical properties measurements. Experimental results demonstrate this facile method is a more promising alternative to the conventional interface and surface modification in high efficient DSSCs.

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1. Introduction

Dye sensitized solar cells (DSSCs) have been considered as a lowcost alternative to conventional silicon-based photovoltaic devices. They have attracted wide attention in academic research and industrial applications since Grätzel et al. [1] reported their breakthrough discovery in 1991. Generally, the power generation in DSSCs is based on photoexcitation of dye molecules, which injects the photoelectrons into a TiO₂ film that leads the electrons toward the external circuit [2]. A mesoporous nanocrystalline structure (TiO₂ nanoparticles constituting film) is essential in order to adsorb sufficient dye molecules for photoelectrons generation and favorably soak hole-carrying electrolyte into photoelectrode. However, it presents two detrimental factors [3]: (i) inefficient electrical transport through the nanocrystalline network, and (ii) high charge recombination. Several studies have endeavored to modify the TiO₂ mesoporous photoelectrodes by adding compact layer at FTO/TiO₂ interface, forming shell or coating on TiO₂ mesoporous film surface, and by doping.

A majority of FTO/TiO₂ interface modification employ TiO₂ as the compact film [4-6], which decreases the back reaction sites on FTO, and yields corresponding improvement of the performance of DSSC. It has been reported that introducing large bandgap semiconducting oxide compact layer to form a potential barrier between FTO substrate and TiO₂ mesoporous layer is feasible for further decrease of the FTO/TiO₂ interfacial charge recombination. Nb₂O₅ [7,8] and ZnO [9] compact layers improve open-circuit photovoltage and fill factor, and keep fairly good short-circuit photocurrent density. A conventional surface modification method is the growing of an extra TiO₂ layer onto the surface of the nanoparticles comprising the TiO_2 mesoporous layer [6,10–13]. The working principle of this coating, as mostly reported [10,12,13], is to improve electron transport across the TiO₂ mesoporous layer by enhancing the connectivity among TiO₂ particles. More recently, metal ions have been employed to tailor the electric conductivity of the photoelectrodes. As reported, a compact Nb-doped TiO₂ thin film has been used to modify the FTO/TiO2 interface of DSSCs, which suppressed the charge recombination from FTO to electrolyte and reduced the interfacial resistance of FTO/TiO₂; hence the charge collection efficiency was further enhanced [14,15]. The electron mobility through TiO₂ mesoporous layer has also been improved by incorporation of atomic impurities into TiO₂ nanoparticles, such as Al [16], Zn [17], Nb [18], and Ta [19]. However, to the best of our knowledge, introducing atomic impurities into the extra TiO₂ layer (as a doped coating on TiO₂ mesoporous layer) and the interaction between

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^{0378-7753/\$ -} see front matter © 2011 Elsevier B.V. All rights reserved. doi:10.1016/j.jpowsour.2011.12.027

 FTO/TiO_2 interfacial modification and mesoporous layer surface modification have not been reported for enhancing the overall energy conversion efficiency of DSSC.

In this article, we combine interfacial modification (formed by adding ZnO compact layer to FTO/TiO_2 interface) with surface modification (by TiCl₄ post-treatment) on photoelectrode. The reaction between these two modifications is expected because of the instability of basic ZnO in acidic TiCl₄ solution. For comparison, photoelectrodes with the combined two modifications, photoelectrodes with single treatment and untreated photoelectrodes are measured by material characterization, current–voltage (*I–V*), dark current, electrochemical impedance spectra (EIS) and Open-circuit voltage decay (OCVD). It is found that, the formed coating on TiO₂ mesoporous layer by TiCl₄ post-treatment is not pure TiO₂ but contain abundant and well dispersed Zn element. Meanwhile, the functions of the two modifications will be changed by combining them together. Hence, the combined effect enhances the overall energy conversion efficiency of DSSCs.

2. Experimental details

2.1. Materials

TiO₂ powders (P25, 20–30 nm, Degussa AG, Germany), ethylene glycol (EG), citric acid (CA), Zinc acetate, ethanolamine (EA), ethylene glycol monomethyl ether, ethanol, HCl, TiCl₄ and propylene carbonate (PC) were obtained from Sinopharm Chemical Reagent Corporation (China). Lithium iodide (LiI, 99%), 4-tertbutylpyridine (TBP) and guanidine thiocyanate (GNCS) were purchased from Acros. Iodine (I₂, 99.8%) was obtained from Beijing Yili chemicals (China). The Ru dye, cis-di(thiocyanato)-bis(2,2′-bipyridyl-4,4′-dicarboxylate) ruthenium(II) (N719), was purchased from Solaronix (Switzerland). All the reagents used were of analytical purity. Fluorine-doped SnO₂ conductive glass (FTO) with sheet resistance 10–15 Ω sq⁻¹ was purchased from Asahi Glass (Japan).

2.2. Preparation of P25 paste and ZnO films on FTO substrates (FTO/ZnO substrates)

 TiO_2 paste was prepared by ball-milling P25 powder with EG for 24 h and then ball-milling the mixture with CA for another 24 h at room temperature. The molar ratio of P25:EG:CA adopted the reported ratio [20] of 7:24:6.

ZnO films were prepared using zinc acetate sol as reported previously [21]. In short, EA was added into 30 ml ethylene glycol monomethyl ether under stirring at room temperature for 30 min, then 6g zinc acetate was added with the molar ratio of EA/Zinc acetate being 1:1. For preparation of ZnO films, the zinc acetate sol was spread via spin-coating on clean FTO substrates with 2300 rpm for 20 s and then sintered at 500 °C for 1 h. The thickness of the ZnO films was around 190 nm as measured by SEM cross section.

2.3. Preparation of photoelectrodes prior to dye adsorption

Photoelectrodes without TiCl₄ post-treatment were prepared by doctor-blading P25 paste on FTO (labeled as 21) and FTO/ZnO (labeled as ZnO+21) substrates, respectively, followed by sintering at 500 °C for 1 h. To P25 mesoporous films with similar thickness, the edges of the conducting glass were covered with two layers of adhesive tapes. The thicknesses of these films were around 14.7 μ m, as measured with a TalyForm S4C-3D profilometer (UK).

Photoelectrodes 2l and ZnO + 2l were post-treated by immersing them in 50 mM TiCl₄ aqueous solution and kept at 70 °C for 30 min, followed by rinsing with deionized (DI) water and annealed at 500 °C in air for 30 min. The TiCl₄ post-treated photoelectrodes 2l and ZnO+2l, were then labeled 2l+TiCl₄ and ZnO+2l+TiCl₄, respectively.

2.4. Photoelectrodes sensitized and device fabrication

The mesoporous electrodes were preheated at $120 \circ C$ for 30 min and then immediately immersed in 0.5 mM N-719/ethanol solution for 24 h at room temperature to allow complete dye adsorption. Afterwards, the electrodes were washed with ethanol to remove accumulated dye molecules. A sandwich-type DSSC configuration was fabricated by clipping the N719 dye-loaded P25 photoelectrode with platinum (Pt) counter electrode and introducing electrolyte between the electrodes, the Pt electrode prepared by sputtering method [22]. The electrolyte was composed of 0.05 M LiI, 0.03 M I₂, 0.1 M 1-propy-3-methylimidazolium iodide, 0.1 M GNCS and 0.5 M 4-tert-butylpyridine in mixed solvent of acetonitrile and PC (volume ratio: 1/1).

2.5. Materials characterization of the photoelectrodes

The morphologies of ZnO, ZnO+2l and ZnO+2l+TiCl₄ were observed by scanning electron microscopy (SEM). X-ray photoelectron spectrum (XPS) was used to determine the chemical characteristics of powder scraped from ZnO+2l and ZnO+2l+TiCl₄, respectively. The binding energy was calibrated by locating the peak of C 1s for adsorbed hydrocarbons at 284.8 eV. Energydispersive X-ray spectroscopy (EDS, GENESIS 7000) was used to determine Zn element dispersion in ZnO+2l+TiCl₄. By ultrasonic dispersing the powder scraped from ZnO+2l+TiCl₄ in deionized water, the morphology of the particles was observed by transmission electron microscopy (TEM). Characteristics changes of the mesoporous films, after interface or surface modification, were surveyed by BET and UV-vis spectra of dye solution desorbing the photoelectrodes with 0.02 M aqueous NaOH.

2.6. Photoelectrical characteristic of DSSCs

The cells were tested by employing a solar light simulator (Oriel, 91192) as the light source and a computer-controlled electrochemical workstation (CHI660C, CH Instruments) as the data recorder. The intensity of the incident light was calibrated by a Si-1787 photodiode (spectral response range: 320-730 nm). The active DSSC area was controlled at 0.25 cm² by a mask. Photocurrent–voltage characteristics (*J*–*V* curves) were measured. Electrochemical impedance spectroscopy (EIS) measurements were performed under the open voltage bias at illumination. The frequency range was 0.01–1 MHz and the magnitude of modulation signal was 0.01 V. Open-circuit voltage decay (OCVD) characteristics were measured by turning off the illumination in a steady state [23] quickly, and recording the transient *V*_{oc} every 100 ms.

3. Results and discussion

3.1. Material characterization of photoelectrodes

3.1.1. Material characterization of ZnO compact layer, ZnO+21

Fig. 1 shows SEM images of ZnO compact layer and ZnO+2l. Fig. 1(a) shows the surface morphology of ZnO layer on FTO substrate. As can be seen from Fig. 1(a), the ZnO layer is flat and compact. Fig. 1(b) shows the cross section SEM image of ZnO+2l, in which we can clearly distinguish ZnO layer from mesoporous P25 layer. The concentration of Zn element in ZnO+2l detected by EDS was around 2.2 at% (Zn/Ti ratio).



Fig. 1. (a) Surface SEM image of ZnO compact layer. (b) Cross section SEM image of ZnO+2l.

3.1.2. Material characterization of $ZnO + 2l + TiCl_4$

Fig. 2(a) shows the SEM cross section image of ZnO + 2l + TiCl₄. As shown in Fig. 2(a), the ZnO layer could not be distinguished from the mesoporous layer. This indicates that the FTO/TiO₂ interface has been changed by TiCl₄ modification. Fig. 2(b) shows the cross section distribution of Zn element in ZnO + 2l + TiCl₄ acquired across the white line. No peaks are found in Fig. 2(b), which demonstrates that there is no gathering area of Zn element, which might mean Zn element is homogeneously distributed across the mesoporous P25 layer. Fig. 2(c) shows the XPS spectra of Zn 2p_{3/2} for powder scraped from ZnO + 2l and ZnO + 2l + TiCl₄. We can clearly identify the Zn $2p_{3/2}$ peak at 1021.4 eV for ZnO + 2l + TiCl₄, but cannot distinguish the Zn $2p_{3/2}$ peak for ZnO+2l. The reason for this could be that the adhesion property between FTO underlayer and ZnO overlayer in ZnO+2l remains relatively strong. Hence the powder scrapped from the photoelectrode ZnO+2l comes mostly from mesoporous P25 layer which contains minute amount of ZnO. Fig. 2(d) shows the XPS spectra of Ti 2p. The Zn/Ti ratio of ZnO+2l+TiCl₄ is 5.7 at% by comparing the peaks of Zn $2p_{3/2}$ with Ti $2p_{3/2}$.

Zn element exists in the mesoporous layer of $ZnO+2l+TiCl_4$ with two probable formation processes: the first is as particles embedded in mesoporous TiO₂ layer, the second is as coating on the surface of TiO₂ nanoparticles, which constitute the mesoporous layer. Fig. 3 shows the TEM images of particles scraped



Fig. 2. (a) Cross section SEM images of ZnO+2l+TiCl₄. XPS of powder scraping from ZnO+2l and ZnO+2l+TiCl₄. (b) Zn 2p_{3/2} of the two powder and (c) Ti 2p of the two powder. (d) EDS Zn element line profiles of ZnO+2l+TiCl₄ acquired across ZnO+2l+TiCl₄ noticed by the white line.



Fig. 3. TEM images of particles scraped from ZnO+2l+TiCl₄.

from $\text{ZnO} + 21 + \text{TiCl}_4$, whose average size is around 25 nm in diameters. It is obvious that Zn/Ti ratio of $\text{ZnO} + 21 + \text{TiCl}_4$ is lower than the 2.2 at% Zn/Ti ratio of ZnO + 21 because part of ZnO in ZnO + 21 would be dissolved in the strong acidic TiCl₄ aqueous solution during TiCl₄ post-treatment. If Zn element exists as particles in $\text{ZnO} + 21 + \text{TiCl}_4$ with similar sizes as P25 nanoparticles, the Zn/Ti ratio of ZnO + 21 + TiCl₄ would be lower than 2.2 at% by XPS measurement, which is obviously contradictory to the result mentioned above (5.7 at%). Based on the above analysis, Zn element mostly exists as a coating on the mesoporous P25 layer in ZnO + 21 + TiCl₄. Owing to the fact that XPS survey provides surface analysis information, most of Zn elements would be probed while most part of Ti elements would be concealed, as a result the Zn/Ti ratio of ZnO + 21 + TiCl₄ by XPS is as high as 5.7 at% as reported above.

3.1.3. BET measurement of four different photoelectrodes

The film density, Brunauer-Emmett-Teller (BET) surface area, porosity and surface area of four types of photoelectrodes are shown in Table 1. It is found that, with the increase of film density of the electrodes by TiCl₄ post-treatment, the later three characteristic parameters of the electrodes all decrease [24]. However, these three parameters of $ZnO + 2l + TiCl_4$ are slightly higher than those of 21+TiCl₄, which could be explained by the fact that the increase of mass of $ZnO + 2l + TiCl_4$ (3.2%) is much less than that of $21 + TiCl_4$ (9.7%). The difference in mass increment could be explained from two aspects. On the one hand, some ZnO would dissolve in acidic TiCl₄ solution, which would lead the slight loss of mass of ZnO+2l+TiCl₄. On the other hand, when Zn^{2+} is present in the aqueous solution, the specific adsorption of Zn^{2+} on TiO₂ nanoparticles could be expected [25,26], which would cause coating by Ti-hydroxide of TiCl₄ solution difficult. It is worth mentioning that Zn²⁺ adsorption onto TiO₂ nanoparticles and latter coverage by Ti-hydroxide may be a rational reason for abundant Zn element remaining as a coating formation in $ZnO + 2l + TiCl_4$.



Fig. 4. UV-vis spectra of dye solution desorbed from 2l, ZnO+2l, $2l+TiCl_4$ and $ZnO+2l+TiCl_4$, respectively.

3.1.4. UV-vis measurement for four different photoelectrodes

Fig. 4 shows UV–vis spectra of dye solution desorbed from photoelectrodes. As the surface area of photoelectrodes is decreased by TiCl₄ modification, as shown in Table 1, the amount of dye absorbed on 2l+TiCl₄ and ZnO+2l+TiCl₄ is less than 2l and ZnO+2l, respectively. While by adding ZnO compact layer, the absorption of ZnO+2l and ZnO+2l+TiCl₄ is much more than 2l and 2l+TiCl₄, respectively. This may be attributed to the higher basicity by containing the Zn element, which favors dye adsorption through carboxylic acid group of the N719 dye. As a result, the amount of dye adsorbed by ZnO+2l+TiCl₄ equals to that absorbed by 2l.

Since $ZnO+2l+TiCl_4$ photoanodes are processed $TiCl_4$ modification (the $TiCl_4$ aqueous solution contains high concentration of HCl), they would stable in acidic environment. It is found that

Table 1

Mass, BET, porosity and surface area characteristics of four different photoelectrodes.

Sample	Film density (g cm ⁻³)	BET $(m^2 g^{-1})$	Porosity ^a (%)	Surface area ^b (m ²)	Mass increased by TiCl ₄ mod.
21	1.54	43.4	63.3	0.374	1
ZnO + 21	1.57	43.1	62.6	0.379	/
$2l + TiCl_4$	1.69	33.8	59.8	0.319	9.70%
$ZnO + 2l + TiCl_4$	1.62	35.7	61.4	0.323	3.20%

^a Porosity has been determined by comparing the film density to a density of 4.2 g cm⁻³ for bulk TiO₂.

^b Electrode (internal) surface area was calculated by multiplication of the mass of a 4 cm², 14.7 µm TiO₂ film and BET.

Table 2Photovoltaic performance parameters of DSSCs.

Sample	$V_{\rm oc}~({\rm mV})$	$J_{\rm sc}$ (mA cm ⁻²)	eff (%)	ff (%)
21	758	14.04	7.36	65.7
ZnO + 21	784	11.99	6.53	66.0
21+TiCl ₄	765	15.46	8.10	65.0
$ZnO + 2l + TiCl_4$	767	16.6	8.88	66.3

 $ZnO + 2l + TiCl_4$ photoanodes are stable during the dye adsorption experiment, and the performances of $ZnO + 2l + TiCl_4$ DSSCs are stable in the whole measurement process.

3.2. The performance of DSSCs employing four different photoelectrodes

Fig. 5(a) shows the photocurrent density-voltage characteristics of DSSCs, while the photovoltaic performance parameters of the cells are listed in Table 2. The short-circuit photocurrent density (J_{sc}) , open-circuit voltage (V_{oc}) and fill factor (ff) of 21 are $14.04 \,\mathrm{mA}\,\mathrm{cm}^{-2}$, 758 mV and 65.7%, respectively, corresponding to an energy conversion efficiency (eff) of 7.36%. After a ZnO spin-coating film at the interface of FTO/TiO₂, ZnO+2l gave an improvement of $V_{\rm oc}$ 26 mV, while $J_{\rm sc}$ decrease to 11.99 mA cm⁻², resulting in the eff decreased to 6.53%. After TiCl₄ post-treating of 2l, the J_{sc} of 2l+TiCl₄ was highly increased to 15.46 mA cm⁻², yielding an increase of eff to 8.1%. After combined two modification of photoelectrodes, ZnO+2l+TiCl₄ gave an improvement of $V_{\rm oc}$ of 9 mV, ff increased to 66.3% and $J_{\rm sc}$ increased by 15.4% (from 14.04 to 16.6 mA cm⁻²), finally resulting in the highest energy conversion efficiency of 8.9%, which was 17.1% higher than that of 21 and 8.8% higher than that of $2l + TiCl_4$.

Fig. 5(b) shows the dark current–voltage characteristics of the DSSCs employing the 2l, ZnO + 2l, $2l + TiCl_4$ and $ZnO + 2l + TiCl_4$ electrodes. The onset dark current occurs at low forward bias for 2l, whereas it shifts by a few hundred millivolts for ZnO + 2l, $2l + TiCl_4$ and $ZnO + 2l + TiCl_4$. ZnO compact layer in ZnO + 2l, $2l + TiCl_4$ and $ZnO + 2l + TiCl_4$. ZnO compact layer in ZnO + 2l can successfully reduce the back reaction sites on FTO substrate, and the dark current can be further suppressed by ZnO as the energy barrier because the conduction band edge of ZnO is more negative than TiO_2 [9]. TiCl_4 post-treatment of $2l (2l + TiCl_4)$ also can suppress the dark current by decreasing electron trap sites on TiO_2 surface [27], which is supported by the enhanced electron lifetime for recombination mentioned in Section 3.3.2. For the combined modification, the dark current of $ZnO + 2l + TiCl_4$ equals that of $2l + TiCl_4$.

3.3. EIS and OCVD analyses

Electrochemical impedance spectroscopy (EIS) analysis is used to investigate the electron-transport and recombination in DSSCs. Fig. 6 shows EIS of DSSCs based on four different photoelectrodes. In the Nyquist plots of EIS spectra shown in Fig. 6(a), there are four sets of semicircles, each set comprising of a small one at high frequency and a large semicircle at low frequency. According to the EIS model reported in literature [8,28,29], the small semicircle which corresponds to the frequency range of $10^3 - 10^5$ Hz ($\omega 1$) is ascribed to the charge transport at the FTO/TiO₂ and Pt counter electrode/electrolyte interfaces (Z1), the large semicircle in the low-frequency region is related to the electron transport within mesoporous layer and across TiO₂/electrolyte interface (Z2). The small semicircle is fitted to a charge-transfer resistance (R1) and a constant phase (Q1), and the large semicircle is fitted to a transport resistance (R2) and a constant phase (Q2) [28]. The fitted parameters including R1 and R2 obtained by Zsimpwin software are exhibited in Table 3. Since an identical Pt counter electrode was used for all the devices, the change at the interface of FTO/TiO_2

Table 3

Fitted parameters including R1 and R2 obtained by Zsimpwin software and electron lifetime calculated by f_{max} of Z2.

Sample	R1 (Ω)	R2 (Ω)	$f_{\rm max}$ of Z2 (Hz)	$\tau_{e}(s)$
21	4.18	14.61	3.742	0.0425
ZnO + 21	6.62	15.4	6.643	0.0239
21+TiCl ₄	5.14	13.24	3.09	0.0516
$ZnO + 2l + TiCl_4$	3.57	13.16	3.09	0.0516

was considered mainly responsible for the difference of R1. As shown in Table 3, ZnO+2l+TiCl₄ exhibits the lowest values for R1 and R2 resistances among the four types of DSSCs, which implies a more efficient charge-transfer process at the interface of FTO/TiO₂, at the dye-coated semiconductor/electrolyte interface and across the mesoporous layer. The Bode phase plots of EIS spectra, as shown in Fig. 6(b), display the frequency peaks of the charge transfer process at different interfaces of four different DSSCs. The characteristic low frequency peak (f_{max}) is located at 3.742 Hz for 2l, 6.643 Hz for ZnO+2l, and 3.09 Hz for 2l+TiCl₄ and ZnO+2l+TiCl₄, respectively. The electron lifetime for recombination (τ_e) of DSSC, as shown in Table 3, is determined by f_{max} values, where $\tau_e = \omega_{min}^{-1} = (2\pi f_{max})^{-1}$ [29]. An increased trend of τ_e is

 $ZnO + 2l < 2l < 2l + TiCl_4 = ZnO + 2l + TiCl_4$.

Open-circuit voltage decay (OCVD) analysis is employed to measure recombination and electron lifetime in DSSCs, since the decay of photovoltage is mainly caused by the charge recombination [23]. Fig. 7 shows OCVD spectra of DSSCs based on the four different kinds of photoelectrodes. Fig. 7(a) shows the photovoltage transient spectra. The V_{oc} decays more slowly for ZnO+2l+TiCl₄ and 2l+TiCl₄ samples, whereas it decays more quickly for ZnO+2l compared with 2l. Fig. 7(b) shows the electron lifetime spectra of OCVD. The electron lifetime was calculated by the formula [23]

$$\tau = \frac{kT}{e} \left(\frac{dV}{dt}\right)^{-1} \tag{1}$$

As shown in Fig. 7(b), the electron life in $ZnO + 2l + TiCl_4$ is similar to that in $2l + TiCl_4$, and is much higher than in 2l. The electron life in each of these three DSSCs is higher than in ZnO + 2l. It should be noted here that the variation trend of the electron lifetime measured by OCVD is the same as the EIS results. The lowest resistance for electron transport and the longest electron lifetime for recombination could favor the highest charge collection rate of photogenerated electrons [29], which led to the highest eff of $ZnO + 2l + TiCl_4$.

3.3.1. Electron transport and recombination at FTO/TiO₂ interface

R1 of 2l (4.18 Ω) is lower than that of 2l+TiCl₄ (5.14 Ω), and ZnO+2l achieved the highest R1 resistance (6.62 Ω). This implies that the above two types of single modification do not facilitate the electron transfer across FTO/TiO₂ interface. The function of ZnO compact layer on DSSC was studied previously in detail [9]. In short, ZnO has a more negative conduction band edge than TiO₂ [3,11,24], which will suppress back electrons transfer from FTO to electrolytes. But this energy barrier would also block the electrons injection from the conductive band of TiO₂ to FTO. The blocking effect would lead to the increase of interfacial resistance of FTO/TiO₂ and the accumulation of electron in the conductive band of TiO₂. The high electron density in the conductive band of TiO₂ will aggravate the back reaction of electron in TiO₂ with I₃⁻ ions present in the electrolyte so that the electron lifetime for recombination (τ_e) of ZnO+2l is lower than that of 2l.

In the case of $ZnO + 2l + TiCl_4$, R1 (3.57 Ω) is the lowest, which implies that the combined modification can reduce the interfacial resistance of FTO/TiO₂. In addition, the electron lifetime for



Fig. 5. Current density-voltage characteristics of DSSCs based on 2l, ZnO + 2l, 2l + TiCl₄ and ZnO + 2l + TiCl₄, respectively, (a) under AM 1.5 illumination 93.2 mW cm⁻² and (b) under dark.



Fig. 6. EIS spectra of DSSCs based on 2l, ZnO+2l, 2l+TiCl₄ and ZnO+2l+TiCl₄, respectively, (a) Nyquist plots and (b) Bode phase plots. The symbols are experimental data, and the solid lines in (a) are fitted results.



Fig. 7. (a) OVCD spectra of DSSCs based on 2l, ZnO+2l, 2l+TiCl₄ and ZnO+2l+TiCl₄, respectively. (b) The electron lifetime calculated from (a).



Fig. 8. Schematic diagrams of electron transport and recombination of photoelectrodes based on (a) 2l, (b) ZnO+2l, (c) 2l+TiCl₄ and (d) ZnO+2l+TiCl₄, respectively. (For interpretation of the references to color in text, the reader is referred to the web version of this article.)

recombination (τ_e) of ZnO+2l+TiCl₄ increased when in comparison with 2l, while in the case of ZnO+2l, it is decreased. This means the FTO/TiO₂ interface of ZnO+2l+TiCl₄ would not lead to electron accumulation in the conductive band of TiO₂, but accelerate the transfer of electron from the conductive band of TiO₂ to FTO.

For the electron recombination at FTO/TiO₂ interface of ZnO+2l+TiCl₄, the impurities in coating, as mentioned above in Sections 3.1.2 and 3.1.3, will facilitate electron back reaction with I₃⁻ ions. As a result, the electron recombination at mesoporous layer of ZnO+2l+TiCl₄ will be higher than that of 2l+TiCl₄ with pure TiO₂ coating. Since the electron lifetime for recombination (τ_e) of ZnO+2l+TiCl₄ equals that of 2l+TiCl₄, so as the dark current, the back reaction at FTO/TiO₂ interface of ZnO+2l+TiCl₄ will be lower than that of 2l+TiCl₄ (The electron recombination with the triiodide occurs at two place: FTO/TiO₂ interface and mesoporous layer surface.). This means there would have an overlayer on FTO which can cover some exposed FTO surface to suppress back electrons transfer from FTO to electrolyte.

3.3.2. Electron transport and recombination at mesoporous layer

For 2l+TiCl₄, resistance of electron transport (R2) and back reaction of electron all decreased, the latter corresponding to the increase of electron lifetime for recombination, these changes illustrate the superiority and necessity of TiCl₄ modification [6].

In the case of $ZnO + 2l + TiCl_4$, the resistance of electron transport (R2) further decreased. After TiCl_4 post-treatment and later sintering, the coating on TiO₂ mesoporous layer surface contains some

Zn element, as mentioned above in Sections 3.1.2 and 3.1.3, which would further facilitate the electron transport at TiO_2 mesoporous layer [17].

3.4. Schematic views of electron transfer

The schematic views of electron transfer with and without modification are shown in Fig. 8. The mesoporous nature of the nanocrystalline TiO_2 film would expose a portion of FTO surface to electrolyte, which leads to the direct back electrons transfer from FTO to electrolyte [30], as shown in Fig. 8(a) and (c). Furthermore, the poor connectivity of the nanocrystalline TiO₂ film would slow down the electron transport across the mesoporous layer, as shown in Fig. 8(a) and (b), and some TiO₂ particles are even isolated from electron pathways that are connected to the conducting substrates (i.e., particles marked with "iso" in Fig. 8) [12]. For single ZnO modification, as shown in Fig. 8(b), back electron transfer from FTO to electrolyte is effectively suppressed by covering the exposed FTO and functioning as energy barrier. However, the ZnO modification would also retard the electron injection from TiO₂ mesoporous layer to FTO (Red represents the blocking function.). For single TiCl₄ modification, as shown in Fig. 8(c), it widens electron pathways by cementing the TiO₂ nanoparticles together to favor electron transfer across mesoporous layer (Light yellow represents the cementing function of coating on mesoporous layer.). For the combined modification, as shown in Fig. 8(d), back electron transfer from FTO to electrolytes would be suppressed by covering the exposed FTO, at

the same time electron transfer across mesoporous layer is favored by the widened electron pathways. Moreover, electron transfer across mesoporous layer and injection from TiO_2 to FTO will be further favored by the synergistic effect (Green represents the facilitated electron transfer function of the synergistic effect between ZnO compact layer and $TiCl_4$ post-treatment.).

4. Conclusion

In summary, we have developed a methodology of photoelectrode modification by combining a basic ZnO compact layer with an acidic TiCl₄ post-treatment. After TiCl₄ post-treatment, the ZnO compact layer transformed to an bi-functional layer at FTO/TiO₂ interface, which suppressed back electrons transfer from FTO to electrolyte and reduced the interfacial resistance between mesoporous TiO₂ layer and FTO. In addition, after adding the basic ZnO overlayer on FTO, the newly formed coating on the surface of TiO₂ mesoporous layer was not pure TiO₂ but contained abundant Zn element, which further facilitated electron transfer and collection. As a result, the overall energy conversion efficiency of DSSC incorporating ZnO layer and TiCl₄ post-treatment was highly enhanced. These results strongly implies that the combined modification is a more attractive method to replace the conventional photoanodes' interface and surface modification for high efficiency DSSCs with high stable.

Acknowledgments

The authors would like to acknowledge the financial support of the National Basic Research Program of China (973 Program, 2011CB933300), and the partial financial support from the National Nature Science Foundation of China (Nos. 50125309 and 10804087).

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